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Substitute for form 1449A/PTO

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Complete if Known

Application No.	10/619,738
Filing Date	July 14, 2003
First Named Inventor	Sabhapathi Naidu Annamaneni
Art Unit	2812
Examiner Name	Not yet known
Attorney Docket Number	22272-08030

Sheet 1 of 1

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document No. Number - Kind Code ² (if known)	Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
Chok		US-2002/0133259 A1	09-19-2002	Hsieh
Chok		US-2002/0169842 A1	11-14-2002	Christensen et al.
Chok		US-2002/0188682 A1	12-12-2002	Jain et al.
Chok		US-2003-0233289 A1	06-14-2002	Lou et al.
Chok		US-2003-0233290 A1	06-14-2002	Lou et al.
Chok		US-2003-0236718 A1	06-14-2002	Yang et al.
Chok		US-6,748,287	06-08-2004	Hagen et al.

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Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ - Number ⁴ Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	T ⁶
Chok	1	WO 03/107116 A2	12-24-2003	Getsilicon, Inc.	
Chok	2	WO 03/107117 A2	12-24-2003	Getsilicon, Inc.	
Chok	3	WO 03/107118 A2	12-24-2003	Getsilicon, Inc.	

OTHER REFERENCES - NON-PATENT LITERATURE DOCUMENTS


Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ⁶
Chok	4	Effective Management of Outsourced Operations: Contending with the New Dynamics and Volatility in the Electronics Supply Chain, 05/2003, FSA. http://www.fsa.org , 6 pages.	
Chok	5	Oracle Shop Floor Management User's Guide, Release 11i, May 2001, Part No. A83717-02, 120 pages [online], [retrieved on 2004-07-14]. Retrieved from the Internet <URL: http://download-west.oracle.com/appsnet/115wsmug.pdf >.	
Chok	6	PIP® Specification, Cluster 7: Manufacturing, Segment B: Manage Manufacturing WO & WIP, 7B1: Distribute Work in Process, http://www.rosettatnet.org , Feb. 28, 2003, 15 pages.	

Examiner Signature		Date Considered	2/27/07
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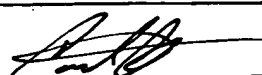
22272/08030/DOCS/1375865.1

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<i>Che</i>	A1	US-2004/0088074 A1	05-06-2004	Chen et al.
<i>Chen</i>	A2	US-2002/0188682 A1	12-12-2002	Jain et al.
<i>Chen</i>	A3	US-2002/0133368 A1	09-19-2002	Strutt et al.8
		US-		
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OTHER REFERENCES – NON-PATENT LITERATURE DOCUMENTS				
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Che	C1	International Search Report and Written Opinion, PCT/US04/22857, February 17, 2006, 7 pages.		
Che	C2	STEVENS, S. et al., "Tighter Process Control and Reduced Cycle Times Using Off-Line Recipe Setup," IEEE/SEMI Advanced Semiconductor Manufacturing Conference, 2000, pp. 199-202.		

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22272/08030/DOCS/1604179.1

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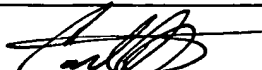
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CROR	1	Hagen, Dr. Klaus ten et al., <u>Technical Overview: WIP Tracking IC Manufacturing workflow and Cycle-time Reduction</u> , eSilicon Corporation, Sunnyvale, USA. Available Aug. 6, 2001 at http://www.esilicon.com , 25 pages.	

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